

Notice of References Cited	Application/Control No. 10/784,979	Applicant(s)/Patent Under Reexamination YACH ET AL.	
	Examiner Shew-Fen Lin	Art Unit 2166	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0116541 A1	08-2002	Parker et al.	709/318
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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